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Application Number	09:241,660
Filing Date	February 2, 1999
First Named Inventor	Gan Yu
Group Art Unit	2826 ZY78
Examiner Name	Gian, M
Attorney Docket Number	UA0024 US NA

(use as many sheets as necessary)

Sheet	1	of	2
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J4985 U.S. PTO
09/930771
08/16/01

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Substitute for form 1449A, PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

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First Named Inventor	Gan Yu
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Group Art Unit	2826 28 78
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Examiner Name	Tran, M
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Attorney Docket Number	UA0024 US NA
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OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

[illegible]

Examiner
Signature

Date
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¹ Unique citation designation number ² Applicant is to place a check mark here if English language Translation is attached

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Form PTO-1449
(Reproduced)INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)

UA-0024 US NA

Application Number

09/241,660

Applicant

YU, ET AL.

Filing Date

FEBRUARY 2, 1999

Group Art Unit

2811 2878

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
TXL	5,164,809	11/17/92 1992	Street	257	55	
TXL	5,262,649	11/16/93 1993	Antonuk, et al.	250	340.09	
TXL	5,331,183	07/19/94	Sariciftci, et al.	257	40	
TXL	5,454,880	10/03/95	Sariciftci et al.	136	263	
TXL	5,504,323	04/02/96	Heeger et al.	250	214.1	
TXL	5,523,555	06/01/96 1996	Marks Friend et al.	250	214R	

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
					YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

TXL	R. A. Street, et al., Spring Meeting of Materials Research Society, San Francisco, April 17-21, 1995
TXL	J. Yorkston, et al., <i>Mat. Res. Soc. Sym. Proc.</i> , 116, 258, 1992
TXL	R. A. Street, <i>Bulletin of Materials Research Society</i> , 11, 17-20, 1992

EXAMINER

DATE CONSIDERED

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 09/930771
 08/16/01
 10986 U.S. PTO

Form PTO-1449 (Revised 10/91) INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) UA-0024 US NA	Application Number 09/241,660
	Applicant YU, ET AL.	
	Filing Date FEBRUARY 2, 1999	Group Art Unit 2811-2878

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

JC986 U.S. PTO
 09/930771
 08/16/01

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

TXL	Eric J. Lerner, <i>Laser Focus World</i> , 32 (12), 54, 1996
TXL	G. A. Chamberlain, <i>Solar Cells</i> , 8, 47, 1983
TXL	S. Karg, et al., <i>Syn. Metals</i> , 54, 427, 1993

EXAMINER	DATE CONSIDERED
<i>[Signature]</i>	12/02

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UA-0024 US NA

09/241,660

Applicant

YU, ET AL.

Filing Date	
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FEBRUARY 2, 1999

Group Art Unit

28112873

U. S. PATENT DOCUMENTS

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TXC	H. Antoniadis, et al., <i>Synth. Metals</i> , 64 , 265, 1994
TXC	G. Yu, et al., <i>Appl. Phys. Lett.</i> , 64 , 1540, 1994
TXC	G. Yu, et al., <i>Appl. Phys. Lett.</i> , 64 , 3422, 1994

EXAMINER

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Docket Number (Optional)
UA-0024 US NA

Application Number	09/241,660
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Applicant YU, ET AL.

Filing Date
FEBRUARY 2, 1999

Group Art Unit 2011-2012 2378

U. S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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TXC	N. S. Sariciftci, et al., <i>Science</i> , 258 , 1474, 1992
TXC	L. Smilowitz, et al., <i>Phys. Rev. B</i> , 47 , 13835, 1993
TXC	N. S. Sariciftci, et al., <i>Intern. J. Mod. Phys B.</i> , 8 , 237, 1994

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FEBRUARY 2, 1999

Group Art Unit

284 2878


U. S. PATENT DOCUMENTS

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TXC	B. Kraabel, et al., <i>Chem. Phys. Lett.</i> , 213 , 389, 1993
TXC	B. Kraabel, et al., <i>Phys. Rev. B</i> , 50 , 18543, 1994
TXC	C. H. Lee, et al., <i>Phys. Rev. B</i> , 48 , 15425, 1993
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Group Art Unit	2811 2878
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TXC	G. Yu, et al., <i>Science</i> , 270 , 1789, 1995
TXC	G. Yu, et al., <i>J. Appl. Phys.</i> , 78 , 4510, 1995
TXC	J. J. M. Halls, et al., <i>Nature</i> , 376 , 498, 1995

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FEBRUARY 2, 1999

Group Art Unit

2011 35 75

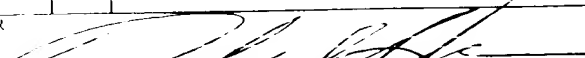
U. S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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TXC	S. M. Sze, <i>Physics of Semiconductor Devices</i> , Part 5, 1981
TXC	A. J. Heeger, et al., <i>Optics & Photonics News</i> , 24, August 1996
TXC	G. Gustafsson, et al., <i>Nature</i> , 357, 477, 1992
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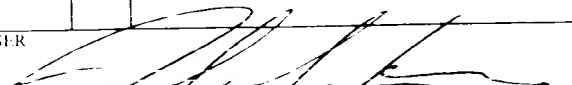
2811 2878**U. S. PATENT DOCUMENTS**

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FOREIGN PATENT DOCUMENTS

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TXC		A. J. Heeger, et al., <i>Optics & Photonics News</i> , 24, August 1996
		R. N. Marks, et al., <i>J. Phys.: Condens. Matter</i> , 6, 1379, 1994
TXC		
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